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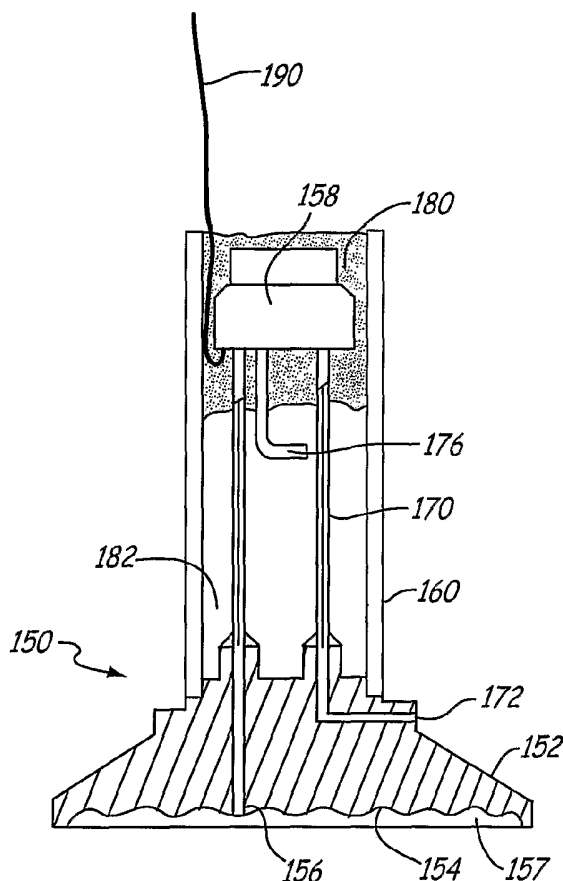
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[Continued on next page]

(54) Title: HIGH TEMPERATURE PRESSURE TRANSMITTER ASSEMBLY

(57) Abstract: A pressure transmitter assembly (106) for mea-
suring a pressure of a process fluid (104) includes an isolation di-
aphragm assembly (120). A pressure sensor (130) is spaced apart
from the isolation diaphragm assembly (120) to provide thermal
isolation. A conduit (122) extends from the isolation diaphragm
assembly (120) to the pressure sensor (130) and is configured to
carry isolation fill fluid.



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HIGH TEMPERATURE PRESSURE TRANSMITTER ASSEMBLY

BACKGROUND OF THE INVENTION

The present invention relates to process
5 control transmitters of the type used in industrial
process monitoring and control systems. More
specifically, the present invention relates to
transmitters which measure process variables in high
temperature environments.

10 Process monitoring and control systems are
used to monitor and control operation of industrial
processes. Industrial processes are used in
manufacturing to produce various products such as
refined oil, pharmaceuticals, paper, foods, etc. In
15 large scale implementations, these processes must be
monitored and controlled in order to operate within
the desired parameters.

"Transmitter" has become a term which is
used to describe the devices which couple to the
20 process equipment and are used to sense a process
variable. Example process variables include pressure,
temperature, flow, and others. Frequently, a
transmitter is located at a remote location (i.e., in
the "field"), and transmits the sensed process
25 variable back to a centrally located control room.
Various techniques are used for transmitting the
process variable including both wired and wireless
communications. One common wired communication
technique uses what is known as a two wire process
30 control loop in which a single pair of wires is used

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to both carry information as well as provide power to the transmitter. One well established technique for transmitting information is by controlling the current level through the process control loop
5 between 4 mA and 20 mA. The value of the current within the 4-20 mA range can be mapped to corresponding values of the process variable.

One type of transmitter is a pressure transmitter. In general, a pressure transmitter is
10 any type of a transmitter which measures a pressure of a fluid of the process. (The term fluid includes both gas and liquids and their combination.) Pressure transmitters can be used to measure pressures directly including differential, absolute or gauge
15 pressures. Further, using known techniques, pressure transmitters can be used to measure flows of the process fluid based upon a pressure differential in the process fluid between two locations.

Typically, a pressure transmitter includes
20 a pressure sensor which couples to the pressure of the process fluid through an isolation system. The isolating system can comprise, for example, a isolation diaphragm which is in physical contact with the process fluid and an isolation fill fluid which
25 extends between the isolation diaphragm and the pressure sensor. The fill fluid preferably comprises a substantially incompressible fluid such as an oil. As the process fluid exerts a pressure on the isolation diaphragm, changes in the applied pressure

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are conveyed across the diaphragm, through the isolation fluid and to the pressure sensor. Such isolation systems prevent the delicate components of the pressure sensor from being directly exposed to the process fluid.

In some process environments, the process fluid may experience relatively high temperatures. However, typically transmitters have a maximum operating temperature of 250-300°F. Even in cases where the transmitter can withstand the high temperature, temperature extremes can still cause errors in pressure measurements. In processes which have temperatures which exceed the maximum temperature of the pressure transmitter, the transmitter itself must be located remotely from the process fluid and coupled to the process fluid using a long capillary tube. The capillary tube can run many feet and an isolation fluid is carried in tube. One end of the tube mounts to the process through an isolation diaphragm and the other end of the tube couples to the pressure transmitter. This long capillary tube and isolation diaphragm is generally referred to as a "remote seal."

The introduction of the remote seal configuration increases the cost and complexity of the installation and reduces the accuracy of the pressure measurements. Further, the additional components provide another source of possible failure of the device.

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SUMMARY

A pressure transmitter assembly for measuring a pressure of a process fluid includes an isolation diaphragm assembly. The isolation diaphragm assembly includes an isolation diaphragm configured to couple to a process fluid along a process interface side and defines an isolated cavity opposite the process interface side. A pressure sensor is mounted to the isolation diaphragm assembly and is physically spaced apart from the isolation diaphragm assembly. A conduit extends from the isolated cavity to the pressure sensor. Temperature compensation can also be used. A method is also provided.

BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a diagram showing a pressure transmitter assembly in which a pressure sensor is spaced apart from an isolation diaphragm assembly to provide thermal isolation.

Figure 2 is a cross-sectional view of a process transmitter offset assembly.

Figure 3 is a cross-sectional view of a pressure transmitter assembly including a transmitter offset assembly.

Figure 4 is a cross-sectional view of another embodiment of a pressure transmitter assembly.

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Figure 5 is a cross-sectional view of a pressure transmitter assembly in accordance with another embodiment.

Figure 6A and Figure 6B are graphs which show the effect of process temperature on components of a pressure transmitter assembly. Figure 6A is directed to a prior art configuration and Figure 6B is directed to a configuration in accordance with the invention.

Figure 7 is a cross-sectional view of a pressure transmitter assembly showing locations of temperature sensors for use in compensating pressure sensor measurements.

DETAILED DESCRIPTION

The present invention is directed to industrial transmitters of type used to measure a process variable of a process fluid in which the process fluid and/or process environment are at a relatively high temperature. With the present invention, the pressure sensor and transmitter electronics are spaced apart from the process fluid to provide thermal isolation from the process fluid. However, the configuration of the present invention does not require the remote seal technique discussed in the background section. Temperature compensation can also be employed.

Electronic industrial pressure transmitters which are employed in the process industry such as pharmaceutical, biotechnology, food and beverage

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technologies and others, often have special requirements. For example, they may often be required to measure the pressure of process fluid at very high temperatures. They are often required to survive very
5 high temperatures during cleaning processes which occur between both "batches" of processing. The cleaning processes are referred to as "Clean In Place" (CIP) and/or "Sterilize In Place" (SIP). These processes expose process interfaces to temperatures
10 of over 200°C. Further, it is desirable that the pressure measurement transmitter not only survive the cleaning process, but also provide minimal error during and after the cleaning process. This allows the next "batch" to begin processing as soon as
15 possible. If the errors are present during the cleaning process, then it is desirable that the measurement device return to its calibration parameters quickly and without a shift in the output following the cleaning process.

20 Conventional industrial pressure transmitter are capable of surviving and performing nominally at temperatures of up to about 85°C. However, beyond this temperature, substantial errors and/or complete failure of the device may occur, for
25 example due to overheating of electronic components. As discussed in the Background section, remote seals (secondary fill systems, also referred to as chemical seals) can be used to meet the needs of high temperature process environments. These seals can

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often survive temperatures beyond 200°C. However, such configurations have a number of drawbacks. For example, substantial measurement errors may be associated with increased process temperature, as
5 much as 1-5%. Further, the configuration may lead to poor temperature transient behavior, i.e., large errors and slow recovery. The configuration also introduces drift and non-repeatable errors when returning from high temperature cleaning to the
10 baseline operating temperature. They may also not be able to accurately measure pressure during the cleaning process.

The industrial pressure transmitter of the present invention provides improved performance in
15 high temperature processes, and in processes which experience intermittent high temperatures such as those experienced during tank cleaning (CIP and SIP). The configuration is well suited to pressure measurement in a hygienic manner as employed in
20 biotechnology, pharmacology, food and beverage processes. The improvements include the increased high process temperature capability and reliability, reduced errors during measurement while under high process temperatures, reduced errors when returning
25 to normal operation from high temperatures, and improved speed of return from transient temperatures induced during CIP and SIP.

Figure 1 is a simplified diagram of an industrial process installation 100 which illustrates

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a pressure transmitter assembly 106 in accordance with the present invention. Process 100 includes a vessel 102 which contains a process fluid 104 therein. The transmitter assembly 106 includes a
5 transmitter offset assembly 110 which mounts transmitter (transmitter module) 108 to vessel 102. Although the transmitter offset assembly 110 is illustrated as a separate component, it may be a component which is integral with the transmitter 108.

10 Offset assembly 110 includes an isolation diaphragm assembly 120, a conduit 122 and a transmitter support 124. The isolation diaphragm assembly 120 includes an isolation diaphragm 128 which has a process interface side which faces and contacts the process fluid 104.

15 An isolated cavity 129 is defined behind the isolation diaphragm 128 and opposite its process interface side. The capillary 122 couples to this cavity 129 and the cavity 129 and capillary 122 are filled with an isolation fill fluid. The isolation
20 fill fluid is of a substantially incompressible liquid such as oil. The end of the capillary 122 which is opposite the isolation diaphragm assembly 120 couples to a pressure sensor 130. The pressure sensor provides an output to transmitter circuitry

25 132. Transmitter circuitry 132 is illustrated as coupled to a two wire process control loop 134. The pressure sensor 130 is electrically coupled to transmitter electronics 132 by electrical connection

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138. In one specific embodiment, electrical connection 138 comprises a flex circuit.

The isolation diaphragm assembly 120 can be of any configuration and the diagram in Figure 1 is provided for illustration purposes only. Similarly, 5 the conduit 122, transmitter 108, pressure sensor 130 and transmitter electronics 132 can be of any desired configuration. The conduit 122 does not need to be straight or tubular as illustrated in Figure 1 and 10 any number of conduits may be employed in alternative configurations.

The transmitter support 124 physically mounts the transmitter 108 to the isolation diaphragm assembly 122 with a spaced apart orientation. Any 15 desired transmitter support or configuration can be used. One example support 124 is one which completely encloses conduit 122 to protect the conduit 122 from the process environment. Another example transmitter support divides the space between vessel 102 and 20 transmitter 108 to create a baffle to reduce or reflect radiation. The spacing between the process vessel 102 and the transmitter 108 provided by the offset assembly 110 provides thermal isolation therebetween. The thermal isolation can be achieved 25 using materials with good insulation properties, through the use of an air gap, or through other techniques. The separation distance between the transmitter 108 and the process vessel 102 can be selected based upon the desired amount of thermal

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isolation for a particular installation. Increased spacing can be used in installations which have particularly hot process temperatures or with transmitters which include electronics or other components which are particularly sensitive to temperature extremes. Unlike the remote seal configuration used in the prior art, the pressure transmitter assembly 106 of the present invention provides a unitary assembly which can be mounted to a process vessel 102 using conventional techniques for mounting a pressure transmitter to a process vessel.

Figure 2 is a cross-sectional view of a process transmitter offset assembly 150 in accordance with another example embodiment. Assembly 150 includes isolation diaphragm assembly 152 having an isolation diaphragm 154 which forms a cavity 157. A pressure conduit 156 extends from the circuitry 157 to a pressure sensor module 158. In the configuration of Figure 2, a vent pressure conduit 170 also extends from sensor module 158 to a vent port 172 and the isolation diaphragm assembly 152. A fill fluid conduit 176 is provided for filling the conduit 156 with fill fluid. A transmitter support 160 surrounds the conduits 156 and 170 and supports the pressure sensor module 158. In the configuration of Figure 2, the transmitter support 160 has a tubular shape, however, any shape can be used. The tube 160 can be formed of any appropriate material. In one specific embodiment, the tube 160 is formed of a relatively

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thin wall of a high temperature plastic. The pressure sensor module 158 is mounted in the support 160 using a potting compound 180. An air gap 182 provides thermal isolation between the isolation diaphragm assembly 152 and the pressure sensor module 158. An electrical connection 190 couples to transmitter electronics which are not shown in Figure 2. The electrical connection 190 can comprise, for example, a flex circuit. The pressure sensor module 158 may contain a temperature sensor (discussed below in greater detail) used for compensating pressure sensor measurements. The potting material 180 provides support structure for the module 158 and may be used to meet intrinsic safety requirements. The air gap 182 may be filled with any desired material and may, for example, constitute a substantial vacuum.

Figure 3 is a cross-sectional view of a pressure sensor transmitter assembly 200 in accordance with another example embodiment. In the embodiment of Figure 3, a pressure transmitter 202 couples to an isolation diaphragm assembly 206 through an offset assembly 204. In this configuration, the offset assembly 204 includes a stainless steel housing 207 which is welded to the isolation diaphragm assembly 206 along weld 208. In the embodiment shown, housing 207 has a tubular shape and provides a transmitter support.

Transmitter 202 includes a transmitter housing 210 and a cover 212. In the configuration of

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Figure 3, the housing 210 is continuous with tubular stainless steel housing 207. Transmitter electronics 220 couples to a pressure sensor 234 through flex circuit 222. Pressure sensor 234 couples to isolation diaphragm assembly 206 through fill fluid conduit 236. The transmitter electronics 220 couples to a terminal block 230 through a feedthrough 228. A field wiring inlet 232 is provided in the housing 210 for coupling to terminal block 230.

Figure 4 is a cross-sectional view of a pressure transmitter assembly 300 in accordance with another example embodiment. Pressure transmitter assembly 300 includes pressure transmitter 302 coupled to offset assembly 304 which includes isolation diaphragm assembly 306. Offset assembly 304 includes a transmitter support 308 which couples to isolation diaphragm assembly 306 at weld 310. Support 308 couples to transmitter body 320 along weld 312. Transmitter circuitry 322 carried within transmitter body 320 couples to a pressure sensor 332 through flex cable 324. Pressure sensor 332 couples to isolation diaphragm assembly 306 through fill fluid conduit 334. Circuitry 322 couples to a connection header 326 through a flex cable 328. The header 326 can provide a connection for a two wire process control loop or other data interface.

Figure 5 is a cross-sectional view of a transmitter assembly 350 in accordance with another example embodiment. Transmitter 350 includes

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transmitter housing 352 having an integral transmitter offset support 354 which couples to a isolation diaphragm assembly 356. A pressure sensor 358 of the pressure transmitter includes a pressure port 360. A conduit 370 extends from the pressure port 360 to the isolation diaphragm assembly 356. An optional temperature sensor 372 is illustrated mounted on pressure sensor 358. Transmitter electrical circuitry 374 electrically couples to pressure sensor 358 and can be coupled to field wiring (not shown in Figure 5) through field wiring port 376. The interior of integral transmitter offset support 354 provides an insulating or isolating volume which can be filled with gas, vacuum, or insulation material to provide the desired thermal isolation. Example insulating materials include RTV (Room Temperature Vulcanized), foam or other material. Such a configuration can operate with process fluids at temperatures over 200°C while maintaining the pressure sensor 358 and transmitter electronics 374 at much cooler temperatures, for example temperatures below 85°C.

Figure 6A is a graph which illustrates the effect of process temperature on various components of a pressure transmitter having a typical prior art configuration and Figure 6B is a graph showing the temperature effects on a transmitter assembly in accordance with one example embodiment of the invention. Figure 6A shows a graph of process

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temperature of zero shift as a percentage of the upper range limit and measured temperature of various components. The graph shows the temperatures of various components when the pressure transmitter is
5 exposed to a range of process temperatures. The graph of the connector temperature shows the sharpest increase as that is located closest to the process. However, the PRT temperature sensor which is positioned next to the pressure sensor also rises
10 substantially to 120°C when the process fluid is at 200°C. Even the transmitter electronic circuitry shows an increase to more than 80°C. The effect of these temperature changes can be seen on the zero reading of the pressure transmitter as the process
15 temperature increases. In contrast, as illustrated in Figure 6B, when the process temperature is increased to 200°C, the pressure sensor temperature only reaches about 65°C. The other lines in Figure 6B show temperatures of other regions of the process
20 transmitter including the inside top region of the housing, the inside air (gap) region, the inside bottom and the neck. The zero shift as a percent of span is also illustrated as the temperature is increased.

25 As mentioned above, in another aspect of the invention, a temperature sensor can be used to provide temperature compensation in conjunction with the temperature isolation. Figure 7 is a cross sectional view of the pressure transmitter of Figure

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5 showing example positions of a temperature sensor in the transmitter 350. Temperature sensor 380 is positioned in the isolation diaphragm assembly, temperature sensor 382 is positioned along the
5 transmitter support structure, temperature sensor 384 is positioned adjacent the pressure sensor and temperature sensor 386 is mounted on the transmitter electronics. These temperature sensors 380-386 are electrically coupled to circuitry in the transmitter
10 350 and are used to provide temperature compensation to the pressure related output provided by the transmitter. Each temperature sensor 380-386 can be used to compensate for different temperature effects on the pressure output. Although four different
15 temperature sensors are shown, in the present invention any number of temperature sensors can be utilized at any desired position. The temperature sensors can be used to dynamically compensate the associated subsystem which they are coupled to.
20 Particular compensation characteristics can be determined through imperial testing or modeling of the pressure transmitter system and logic and can be used to reduce transient errors. The temperature sensors can be placed at positions within the
25 transmitter to provide compensation which is proportionate to the relative magnitude of the error due to temperature changes of components in the vicinity of the sensor.

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The present invention provides a technique for isolating pressure transmitters from a high temperature process connection. A unitary pressure transmitter assembly includes the pressure transmitter in a spaced-apart configuration from an isolation diaphragm assembly. This configuration allows the circuitry and pressure sensor to be operated at a cooler temperature while the process connection may be a temperature of 230°C or greater.

5

10 The modular construction allows the invention to be implemented in a wide range of applications and allows for the use of simple and low cost assembly techniques while minimizing inventory requirements. The thermal isolation can be increased by changing

15 the materials used in the support structure and/or lengthening the support structure. Temperature sensors can be used for compensation of the measured process variable in accordance with known techniques. However, in addition to placing a temperature sensor

20 for compensation near the pressure sensor, in one example embodiment a temperature sensor is placed near the isolation diaphragm assembly. The pressure sensor can be used to measure gauge, absolute and differential pressures. A temperature sensor can be

25 provided on electronic circuit board for temperature compensation. The temperature sensor can be thermally coupled to the pressure sensor by a thermally conductive material for use in compensating for temperature variations.

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Although the present invention has been described with reference to preferred embodiments, workers skilled in the art will recognize that changes may be made in form and detail without departing from the spirit and scope of the invention. Any type of isolation diaphragm assembly can be used and the invention is not limited to those specifically set forth herein. Similarly, other pressure transmitter configurations may be utilized.

10 The isolation fill fluid can be of any type of configuration or shape. Any type of pressure sensor, isolation diaphragm or transmitter electronics can be employed as desired. The pressure transmitter module used in the pressure transmitter assembly used in the

15 present invention can have an configuration and typically, although not exclusively, will include transmitter electronics and/or a pressure sensor. In one embodiment, the spacing between the isolation diaphragm and the pressure sensor is more than about

20 1.3 inches. In another example embodiment, the thermal conductivity as measured from the isolation diaphragm to the pressure sensor is less than about 1 W/m K. The transmitter support structure can be formed of a separate component which is mounted to

25 the transmitter assembly module and/or the isolation diaphragm assembly, or it can be a component which is formed integrally with the pressure transmitter module and/or the isolation diaphragm assembly. The pressure sensor can be located in the transmitter

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module, in the transmitter support, or in another location as desired.

WHAT IS CLAIMED IS:

1. A pressure transmitter assembly for measuring a pressure of a process fluid, comprising:
 - an isolation diaphragm assembly including an isolation diaphragm configured to couple to a process fluid along a process interface side and defining an isolated cavity opposite the process interface side;
 - a pressure sensor coupled to the isolation diaphragm assembly and physically spaced apart from the diaphragm assembly to provide thermal isolation from process fluid proximate the isolation diaphragm assembly; and
 - a conduit extending from the isolated cavity defined by the isolation diaphragm to the pressure sensor, the conduit configured to carry isolation fill fluid to thereby transfer a pressure applied to the isolation diaphragm to the pressure sensor.
2. The apparatus of claim 1 including a transmitter support which couples a transmitter module to the isolation diaphragm assembly.
3. The apparatus of claim 2 wherein the transmitter support has a relatively low thermal conductivity.
4. The apparatus of claim 2 wherein the transmitter support comprises a support formed with a relatively thin wall.

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5. The apparatus of claim 2 wherein the transmitter support is tubular.
6. The apparatus of claim 2 wherein the transmitter support comprises a plastic.
7. The apparatus of claim 2 wherein the transmitter module couples to the transmitter support with a potting compound.
8. The apparatus of claim 2 wherein the spacing between the isolation diaphragm assembly and the pressure transmitter module includes an air gap.
9. The apparatus of claim 1 wherein the isolation diaphragm assembly includes a vent port.
10. The apparatus of claim 9 including a vent pressure tube extending between the pressure transmitter module and the vent port.
11. The apparatus of claim 1 including a sensor module which includes a pressure port.
12. The apparatus of claim 11 including a pressure transmitter module having an electrical connection coupled to circuitry in the sensor module.
13. The apparatus of claim 12 wherein the pressure transmitter module includes output electronics electrically coupled to circuitry in the sensor module by the electrical connection.
14. The apparatus of claim 12 wherein the electrical connection comprises a flex circuit.
15. The apparatus of claim 1 including a temperature sensor for use in compensating variations

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in pressure measurements due to temperature variations.

16. The apparatus of claim 1 including a plurality of temperature sensors for use in compensation variations in pressure measurements due to temperature variation.

17. The apparatus of claim 1 including a thermally conductive material which thermally couples the pressure sensor to a thermal sensor carried on an electronic circuit board in the pressure transmitter.

18. The apparatus of claim 1 wherein a space between the pressure sensor and the isolation diaphragm is more than about 1.3 inches.

19. The apparatus of claim 1 wherein the thermal conductivity from the isolation diaphragm to the pressure sensor is less than about 1 W/M °K.

20. A method of manufacturing a pressure transmitter for coupling to a high temperature process fluid comprising:

providing an isolation diaphragm assembly including an isolation diaphragm configured to couple to a process fluid along a process interface side and defining an isolated cavity opposite the process interface side;

providing a pressure sensor;

affixing the pressure sensor to the isolation diaphragm assembly at a physically spaced apart position from

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the diaphragm assembly to provide thermal isolation from process fluid proximate the isolation diaphragm assembly; and

coupling the isolated cavity defined by the isolation diaphragm to the pressure sensor with a conduit, the conduit configured to carry isolation fill fluid to thereby transfer a pressure applied to the isolation diaphragm to the pressure sensor.

21. The method of claim 20 wherein the affixing includes providing a transmitter support which couples to the isolation diaphragm assembly.

22. The method of claim 21 wherein the transmitter support has a relatively low thermal conductivity.

23. The method of claim 21 including filling the transmitter support with a potting compound.

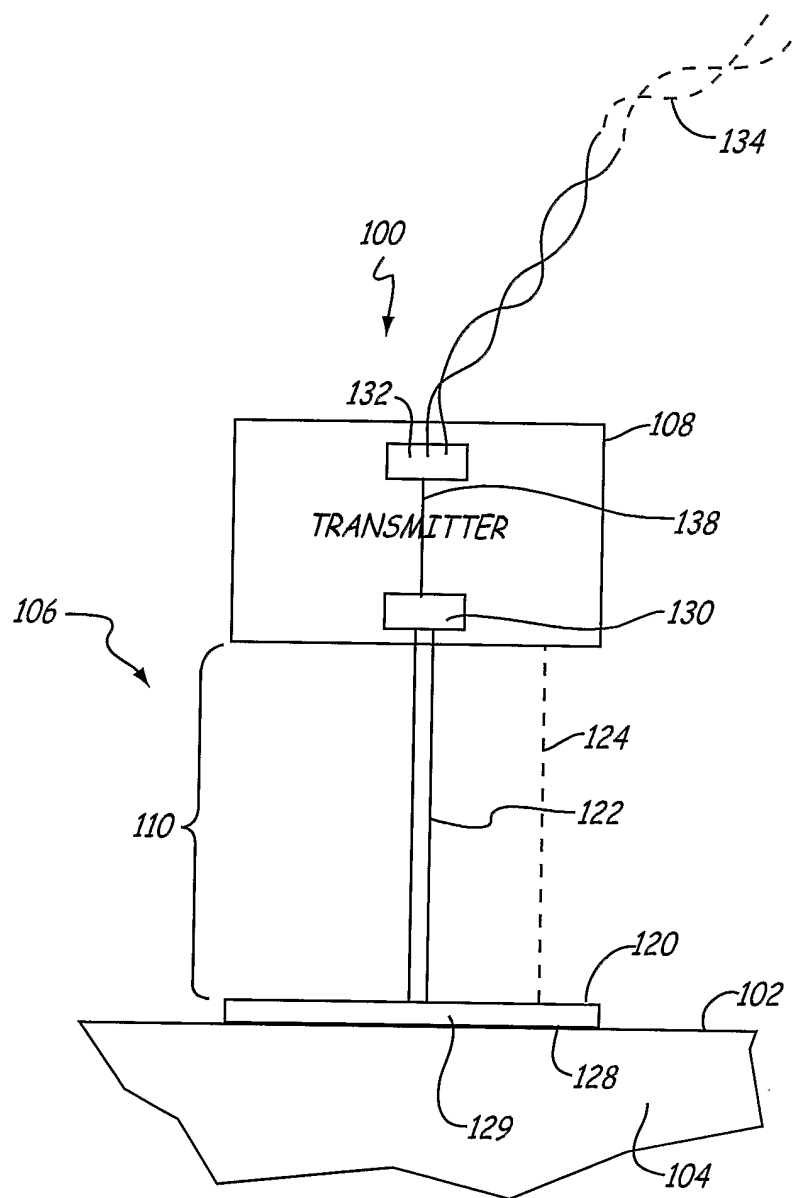
24. The method of claim 20 wherein the isolation diaphragm assembly includes a vent port and the method includes coupling a pressure transmitter module to the vent port.

25. The method of claim 20 including providing a temperature sensor for use in compensation variations in pressure measurements due to temperature variations.

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26. The method of claim 25 including providing a plurality of temperature sensors for use in providing temperature compensation.

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*Fig. 1*

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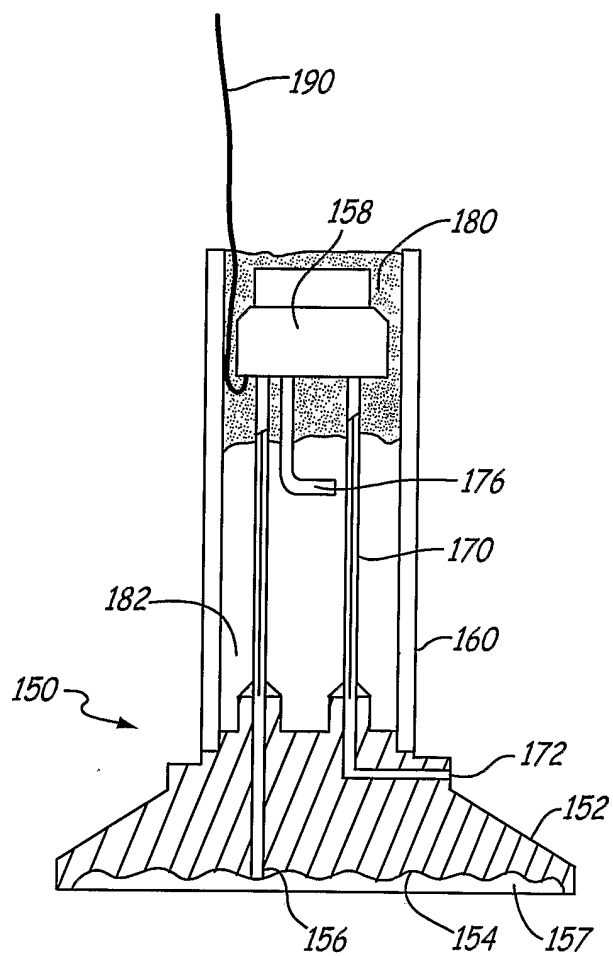
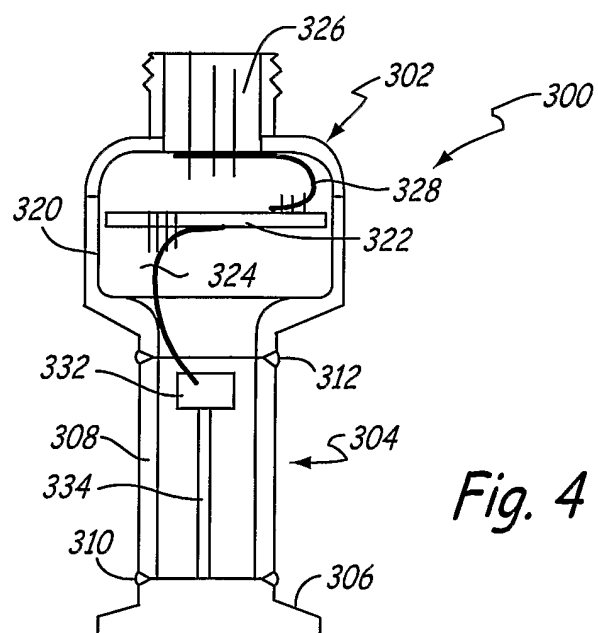
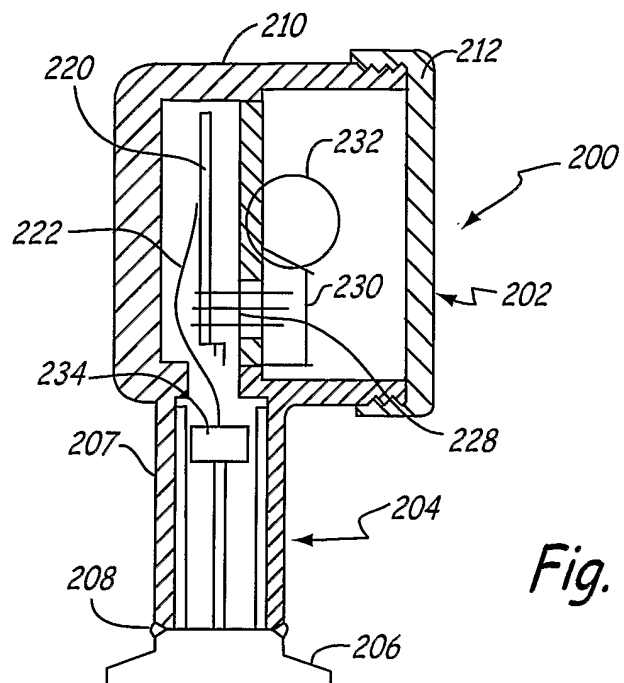
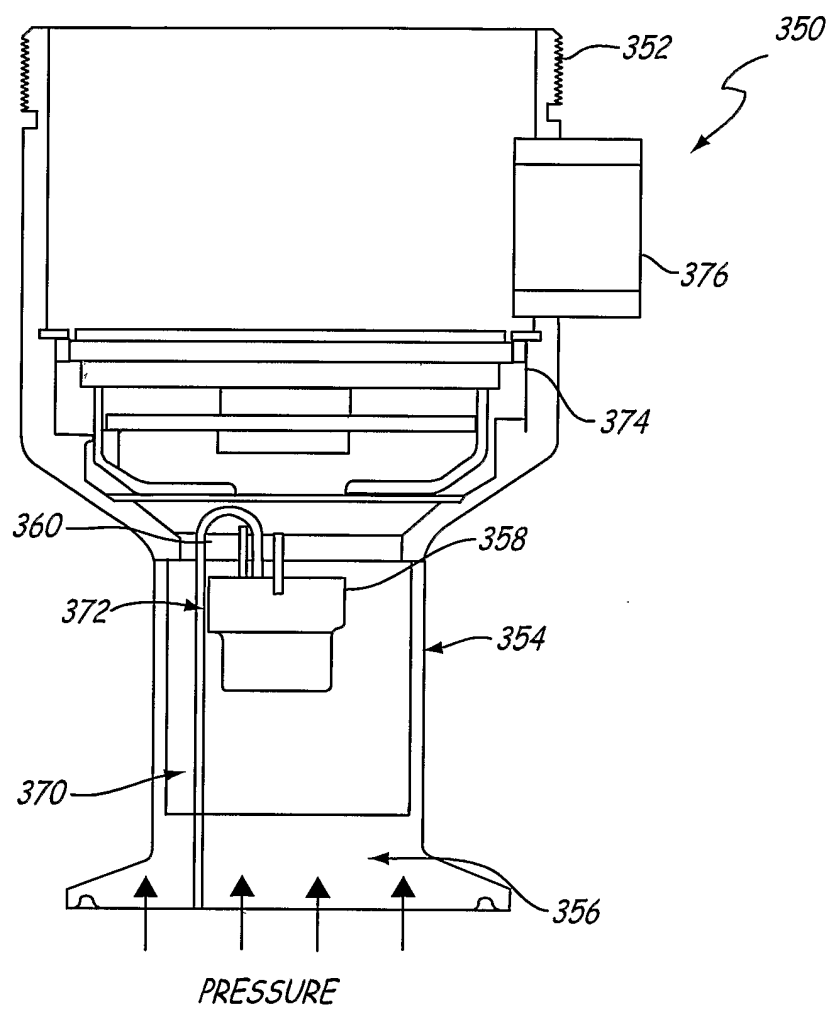


Fig. 2

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*Fig. 5*

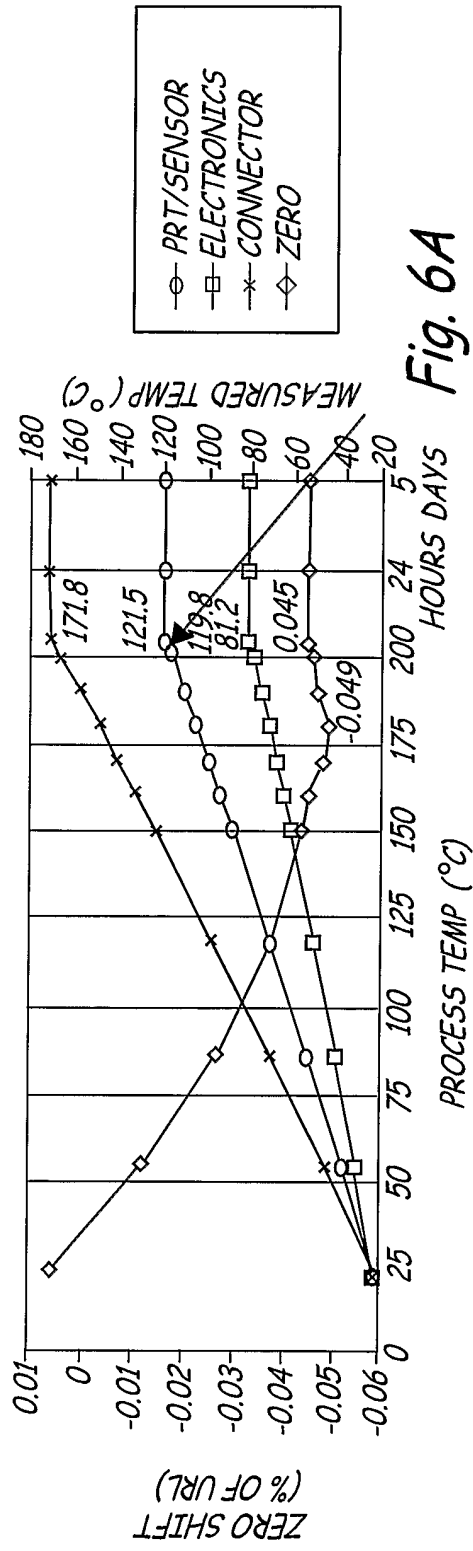


Fig. 6A

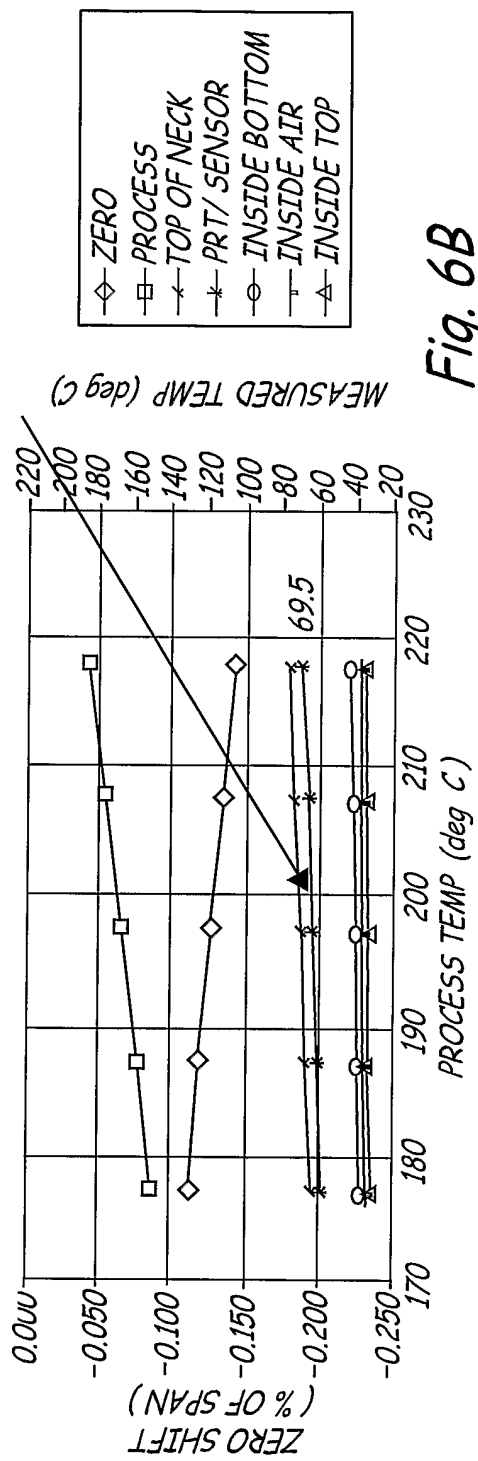
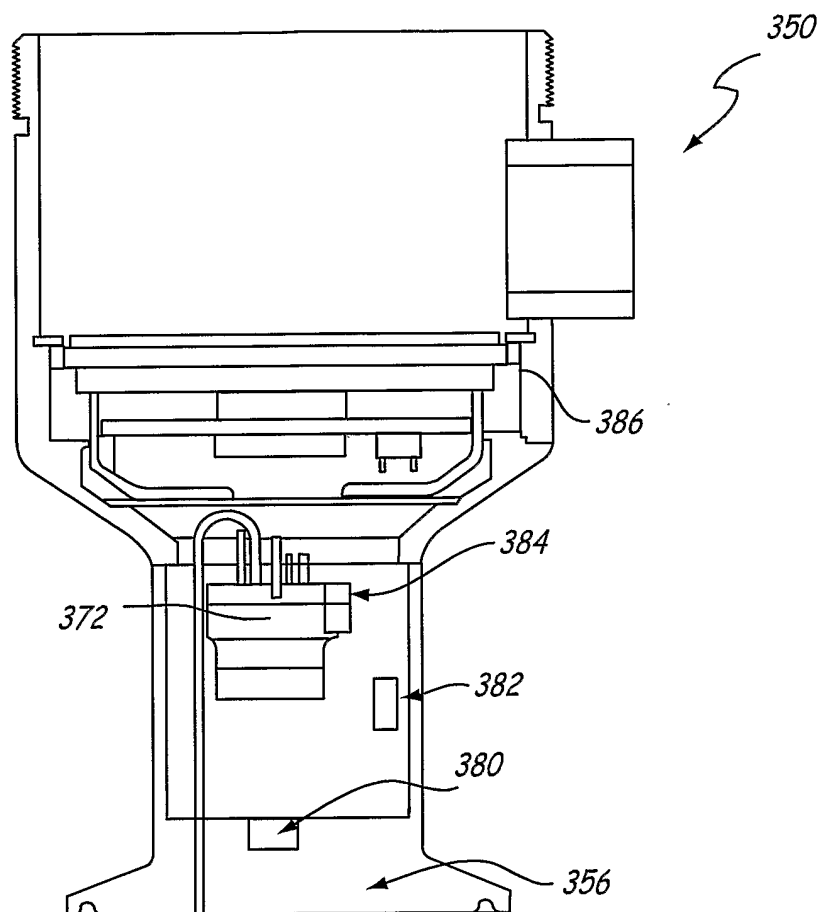


Fig. 6B

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*Fig. 7*

INTERNATIONAL SEARCH REPORT

International Application No

PCT/US2005/021151

A. CLASSIFICATION OF SUBJECT MATTER
 IPC 7 G01L19/04 G01L19/00 G01L19/06

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 G01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	WO 96/27124 A (ROSEMOUNT INC) 6 September 1996 (1996-09-06) abstract; figures	1,8,12, 13, 15-17, 20,25,26
X	PATENT ABSTRACTS OF JAPAN vol. 1999, no. 09, 30 July 1999 (1999-07-30) & JP 11 094671 A (YOKOGAWA ELECTRIC CORP), 9 April 1999 (1999-04-09) abstract; figures	1-5, 20-22
X	EP 0 306 189 A (VALEPORT MARINE SCIENTIFIC LIMITED) 8 March 1989 (1989-03-08) abstract; figure 2	1,2,4-6, 11,20,21
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☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

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Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	EP 1 255 099 A (TRAFAG AG) 6 November 2002 (2002-11-06) abstract; figures	7, 18, 23
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